

03-28-05

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Dated: March 25, 2005

Signature:

Enrique Moreno
(Enrique Moreno)

Docket No.: 199372002501

Client reference: 143150US

(PATENT)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Patent Application of:
Takayuki TOSHIMA et al.

Confirmation No.: 4004

Application No.: 10/606,135

Examiner: Joseph L. Perrin

Filed: June 25, 2003

Art Unit: 1746

For: SUBSTRATE PROCESSING APPARATUS
FOR RESIST FILM REMOVAL
(AS AMENDED)

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated October 27, 2004, for which a response was due on January 27, 2005, and for which a two-month extension of time is also requested to extend the time for response from January 27, 2005, to March 28, 2005 (the first business day following March 27, 2005), please amend the above-identified patent application as follows.

SUMMARY OF AMENDMENTS

SPECIFICATION

☒ There are amendments to the specification.

CLAIMS

☐ There are no amendments to the claims.

☒ A complete listing of all claims ever present in this case in ascending order with status identifier is presented in a separate section.

Application No.: 10/606,135

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Docket No.: 199372002501

TITLE

Please amend the title as follows:

SUBSTRATE PROCESSING ~~METHOD AND APPARATUS~~ FOR RESIST FILM REMOVAL